

**TROP, PRUNER & HU, P.C.**

INTELLECTUAL PROPERTY LAW ATTORNEYS

1616 South Voss Road, Suite 750

Houston, Texas 77057-2631

Bus: (713) 468-8880

Fax: (713) 468-8883

**RECEIVED  
CENTRAL FAX CENTER**

OCT 26 2006

**Fax**

<b>To:</b>	Examiner Hadi Shakeri	<b>From:</b>	Timothy N. TROP
<b>Company:</b>	US Patent Office	<b>Date:</b>	October 26, 2006
<b>Fax:</b>	(571) 273-8300	<b>Pages:</b>	5 (including cover sheet)
<b>Your Re:</b>	10/762,849	<b>Our Re:</b>	ITL0941US

☐ Urgent    ☐ For Review    ☐ Please Comment    ☐ Please Reply    ☐ Confirm Receipt

**MESSAGE:**

● **Notice:** This information is intended to be for the use of the individual or entity named on this transmittal sheet. If you are not the intended recipient, be aware that any disclosure, copying, distribution, or use of the contents of this faxed information is prohibited. If you have received this facsimile in error, please notify the sender by telephone immediately so that arrangements can be made for the retrieval of the original document at no cost to you.

**RECEIVED  
CENTRAL FAX CENTER**

OCT 26 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Matthew Prince et al.	§	Art Unit:	3723
Serial No.:	10/762,849	§	Examiner:	Hadi Shakeri
Filed:	January 22, 2004	§	Docket:	ITL.0941US P15694
For:	Reducing Wafer Defects from Chemical Mechanical Polishing	§	Assignee:	Intel Corporation

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO FINAL REJECTION**

Sir:

In response to the final rejection mailed October 11, 2006, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

Date of Deposit: October 26, 2006  
I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571-773-8300) on the date indicated above.  
*Cynthia L. Hayden*  
Cynthia L. Hayden